



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Attorney Docket No. 2003\_1364A

Takashi OHSAKO et al.

**Confirmation No. 8585**

Serial No. 10/677,221

Group Art Unit 2895

Filed October 3, 2003

Examiner Joannie A. Garcia

METHOD OF MANUFACTURING  
SEMICONDUCTOR ELEMENT

**Mail Stop: AMENDMENT**

---

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 11, 2009, a Petition for a two month extension of time being submitted herewith, please amend the above-identified application as follows.